

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Eiichi SHIMIZU et al.

Application No.: 10/589,348

Confirmation No.: 8171

Filed: August 11, 2006

Art Unit: 1792

For: VAPOR PHASE GROWTH APPARATUS

Examiner: R. N. Kackar

**STATEMENT OF SUBSTANCE OF INTERVIEW IN
ACCORDANCE WITH MPEP §713.04**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants thank the Examiner for the time, helpfulness and courtesies extended to Applicants' representatives during the Interview of September 18, 2009. The assistance of the Examiner in advancing prosecution of the present application is greatly appreciated. In compliance with M.P.E.P. § 713.04, Applicants submit the following remarks.

The Interview Summary form issued on October 8, 2009 summarizes the discussions at the Interview. The outstanding rejection of the claims was discussed. The Examiner proposed an Examiner's Amendment to the Claims. Applicants approved of the proposed amendment.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§ 1.16 or 1. 17; particularly, extension of time fees.

Dated:

JAN 7 2010

Respectfully submitted,

By 

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